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Information Disclosure Statement by Applicant <small>(Use several sheets if necessary)</small> <small>(37 CFR §1.98(b))</small>				Applicant Masato Yonezawa et al.			
				Filing Date February 11, 2004		Group Art Unit	

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Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
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							Yes No

Examiner Signature	Long Pham	Date Considered
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